

	U.S. Department of Commerce Patent & Trademark Office		Attorney Docket No. 622/48561	Serial No. 09/484,421
	Applicant: Martin DUBS, et al.			
	Filing Date January 18, 2000		Group	

U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
<i>gc</i>	AA	5415729	05/1995	Strasser, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	TRANSLATION	
							Yes	No
gc	AK	0273550	07/1988	Europe				
gc	AL	0449227	10/1991	Europe				
gc	AM	0312694	12/1989	Europe				Abstract
gc	AN	4104592	08/1992	Germany				Abstract
gc		60238133	11/1985	Japan				Abstract
gc		60131967	07/1985	Japan				Abstract
gc	AO	10121237	05/1998	Japan				Abstract
gc	AP	2141568	05/1990	Japan				Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)									
<i>gc</i>	AQ	R. H. HORNG, et al. "Effects of rapid thermal process on structural and electrical characteristics of Y ₂ O ₃ thin films by r.f.-magnetron sputtering" Thin Solid Films, 1996							
<i>gc</i>	AR	Copy of Search Report							
	AS								

EXAMINER <i>H Can</i>	DATE CONSIDERED 4/12/02
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.	